## Notice of References Cited Application/Control No. O9/872,659 Examiner Andrew L. Nalven Applicant(s)/Patent Under Reexamination JABLON, DAVID P. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,535,276	07-1996	Ganesan, Ravi	713/155
	В	US-5,557,346	09-1996	Lipner et al.	380/286
	С	US-5,717,756	02-1998	Coleman, David Allen	713/155
	۵	US-6,044,155	03-2000	Thomlinson et al.	713/155
	E	US-6,161,185	12-2000	Guthrie et al.	713/201
	F	US-6,226,383	05-2001	Jablon, David P.	380/30
	G	US-6,311,276	10-2001	Connery et al.	713/201
	Η	US-6,510,513	01-2003	Danieli, Damon V.	713/156
	-	US-			
	7	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q				.,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,	
	R					
	Ø					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	٧	
	w	
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYYY format are publication dates. Classifications may be US or foreign.